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Application Information

Title Line One:: EXPOSURE METHOD AND APPARATUS, AND

Title Line Two:: METHOD OF FABRICATING A DEVICE Title Line Three::

Title Line Four::

Total Drawing Sheets:: 7

Docket Number:: 107629

Continuity Information

>This application is a::

Application One:: Filing Date:: Patent Number::

which is a::

>>Application Two::

Filing Date::
Patent Number::

Prior Foreign Applications

Foreign Application One:: JP

Filing Date::

Country::

Priority Claimed::

Foreign Application Two::

Filing Date::

Country::

Priority Claimed::

Foreign Application Three::

Filing Date::

Country::

Priority Claimed::

JP 11-299331

October 21, 1999

Japan yes